

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/605,323	09/23/2003	CHIH-HUNG CHIANG	10680-US-PA	2322	
31561	7590 07/27/2005		EXAMINER		
JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE			NGUYEN, THANH NHAN P		
7 FLOOR-1, ROOSEVEL	NO. 100 T ROAD, SECTION 2		ART UNIT	PAPER NUMBER	
,	00		2871		
TAIWAN			DATE MAILED: 07/27/2005		

Please find below and/or attached an Office communication concerning this application or proceeding.

			42
	Application No.	Applicant(s)	
	10/605,323	CHIANG ET AL.	
Office Action Summary	Examiner	Art Unit	
	(Nancy) Thanh-Nhan P. Nguyen	2871	
The MAILING DATE of this communication appeariod for Reply	pears on the cover sheet with the o	correspondence add	iress
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a rep - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailine earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a reply be tir ly within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from e, cause the application to become ABANDONE	nely filed s will be considered timely, the mailing date of this con CO (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on 22 A	April 2005.		>
2a) ☐ This action is FINAL . 2b) ☑ This	s action is non-final.		•
3) Since this application is in condition for allowa	ince except for formal matters, pro	osecution as to the	merits is
closed in accordance with the practice under	Ex parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.	
Disposition of Claims	•		
4)⊠ Claim(s) <u>1,4-8 and 10-20</u> is/are pending in the	e application.		•
4a) Of the above claim(s) is/are withdra	wn from consideration.		
5) Claim(s) is/are allowed.			
6)☐ Claim(s) is/are rejected.			
7) Claim(s) is/are objected to.			
8)⊠ Claim(s) <u>1,4-8,10-20</u> are subject to restriction	and/or election requirement.		
Application Papers			
9)☐ The specification is objected to by the Examine	er.		
10) The drawing(s) filed on is/are: a) acc	cepted or b) objected to by the	Examiner.	
Applicant may not request that any objection to the	drawing(s) be held in abeyance. Se	e 37 CFR 1.85(a).	
Replacement drawing sheet(s) including the correct	ction is required if the drawing(s) is ob	jected to. See 37 CF	R 1.121(d).
11)☐ The oath or declaration is objected to by the E	xaminer. Note the attached Office	Action or form PT	O-152.
Priority under 35 U.S.C. § 119			
12) ☐ Acknowledgment is made of a claim for foreign	n priority under 35 U.S.C. § 119(a)-(d) or (f).	
a) ☐ All b) ☐ Some * c) ☐ None of:			
1. Certified copies of the priority documen	ts have been received.		
2. Certified copies of the priority documen	ts have been received in Applicat	ion No	
3. Copies of the certified copies of the price	ority documents have been receive	ed in this National S	Stage
application from the International Burea	u (PCT Rule 17.2(a)).		
* See the attached detailed Office action for a list	t of the certified copies not receive	ed.	
Attachment(s)	. <u>–</u>	•	
Notice of References Cited (PTO-892)	4) Interview Summary Paper No(s)/Mail D		
2) Interpretation Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	- ,		-152)
Paper No(s)/Mail Date	6) Other:	•	•

Application/Control Number: 10/605,323

Art Unit: 2871

DETAILED ACTION

This communication is responsive to amended dated 4/22/2005.

Election/Restrictions

Restriction to one of the following inventions is required under 35 U.S.C 121:

I. Claims 1, 4-7, and 15-20, drawn to a pixel structure for a thin film transistor array, classified in class 349, subclass 43.

II. Claims 8, and 10-14, drawn to a method of fabricating a pixel structure for a thin film transistor array, classified in class 349, subclass 187.

The inventions are distinct, each from the other because of the following reasons:

Inventions II and I are related as process of making and product made. The inventions are distinct if either or both of the following can be shown: (1) that the process as claimed can be used to make other and materially different product or (2) that the product as claimed can be made by another and materially different process (MPEP § 806.05(f)). In the instant case, when manufacturing a pixel structure, in order to prevent the pixel storage capacitor from leakage, one of the methods is to form an amorphous silicon layer below the contact window, and use the amorphous silicon layer as a stop layer to prevent the gate insulating layer below the contact window from etching through. Invention II has separate utility such as not forming the contact window above the pixel storage capacitor, and therefore the leakage will not occur even if the passivation layer and the gate insulating layer are etched through.

Because these inventions are distinct for the reasons given above, and the search required for Group I and II differently, restriction for examination purposes as indicated is proper.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of inventorship must be accompanied by a request under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(i).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to (Nancy) Thanh-Nhan P. Nguyen whose telephone number is 571-272-1673. The examiner can normally be reached on M-F/9-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim can be reached on 571-272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 10/605,323

Art Unit: 2871

Page 4

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

July 22, 2005

TN

ROBERT H. KIM
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800